



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 14, 2025

IGI Report Number **LG728502159**

Description **LABORATORY GROWN DIAMOND**

Shape and Cutting Style **SQUARE EMERALD CUT**

Measurements **10.85 X 10.56 X 6.88 MM**

GRADING RESULTS

Carat Weight **7.16 CARATS**

Color Grade **G**

Clarity Grade **VS 2**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**

Symmetry **EXCELLENT**

Fluorescence **NONE**

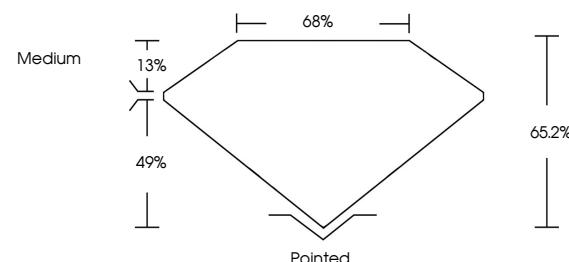
Inscription(s) **IGI LG728502159**

Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.

Type IIa

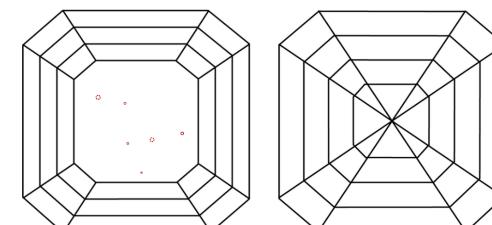
LG728502159
Report verification at igi.org

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

www.igi.org

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August 14, 2025	IGI Report No LG728502159	SQUARE EMERALD CUT	Carat Weight	7.16 CARATS
		10.85 X 10.56 X 6.88 MM	Color Grade	G
			Clarity Grade	VS 2
			Depth	65.2%
			Table Grade	65%
			Culet	Medium
			Polish	Pointed
			Symmetry	EXCELLENT
			Fluorescence	NONE
			Inscription(s)	IGI LG728502159

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